



VMZ-S 3020



CNC Video Measuring System NEXIV

MICROSCOPY • METROLOGY SERVICES
Sjesei made



We show quality
Nous rendons la qualité visible
Wir machen Qualität sichtbar



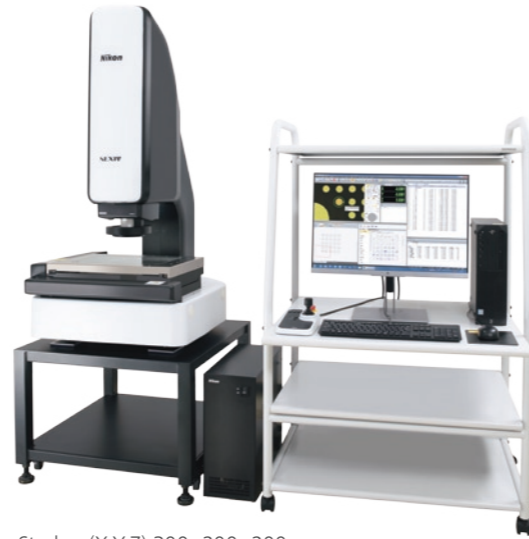
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NEXIV VMZ-S

High accuracy / High speed / Easy tolerance management at micro level.

Equipped with Nikon's excellent optical design

6 types of optical heads are each equipped with a 15x zoom capability, offering an optimum solution.



Strokes (X,Y,Z) 300x200x200 mm

Standard magnification zooming heads (Type 1, 2, and 3)

Zooming heads	Optical magnification	Total magnification	FOV size on stage (mm)	Minimum measurement diameter (as a guide)*	
Standard magnification	Type 1	0.5 – 7.5x	18 – 270	9.33x7 – 0.622x0.467	221 – 15 μm
	Type 2	1 – 15x	36 – 540	4.67x3.5 – 0.311x0.233	111 – 8 μm
	Type 3	2 – 30x	72 – 1080	2.33x1.75 – 0.155x0.117	56 – 4 μm

Connector, IC package, PCB, MLCC, Lead frame, Camera Module, Glass and Plastic Lenses, etc.

High magnification zooming head (Type 4 and TZ)

High magnification	Type 4	4 – 60x	144 – 2160	1.17x0.88 – 0.078x0.058	34 – 2.2 μm
	Type TZ	1 – 120x	36 – 4320	4.67x3.5 – 0.039x0.029	111 – 0.9 μm

High density printed circuit board, fine semiconductor package, Micro Electro Mechanical (MEMS) parts, etc.

Wide FOV zooming head (Type A)

Wide FOV	Type A	0.35 – 3.5x	12.6 – 126	13.3x10 – 1.33x1	327 – 33 μm
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Molded parts, Sheet metal stampings, rubber seals and parts, mechanical components, etc.

*This is not a guaranteed value. Sample: Calibration plate. diascopic light and measurement within FOV (without stage move). Diameter is calculated by creating least-squares circle from 36 measurement points. Please use this as a guide when choosing head types.



Printed circuit board (optical magnification 2x) Type 2 / 8 segment LED ring light

IC chip (optical magnification 8x) Type 4 / coaxial top light

Resin parts (optical magnification 0.35x) 8 segment LED ring light

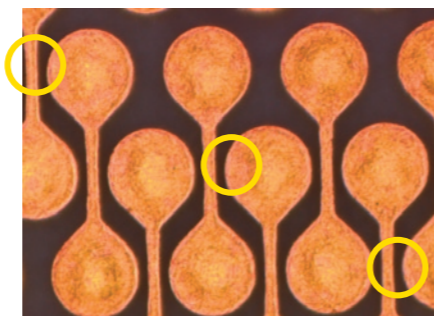
High accuracy within the field of view (FOV)

Accuracy within FOV (P_{F2D} , P_{FV2D}) is specified. Nikon designed optics deliver high-quality images and realize accurate measurement data.

Probing error*	P_{F2D} 0.8 μm
Probing error of the imaging probe*	P_{FV2D} 0.3 μm

*Type2 zooming head. Determined by Nikon in-house measurement method. Measurement of the perimeter of circular reference device. It involves stage movement which caliper within the FOV is evenly placed at 25 points on the perimeter.

*Type2 zooming head. Determined by Nikon in-house measurement method. Measurement of 25 points that are evenly placed on the perimeter of circular reference device at one location on the screen (without stage movement).



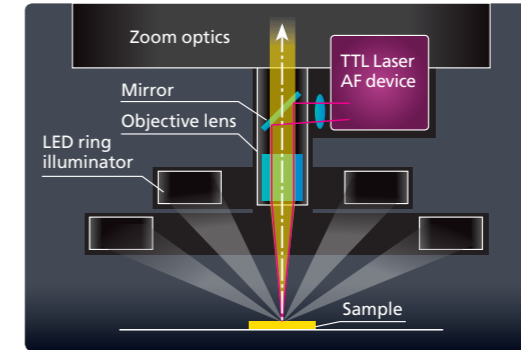
Micro wiring patterns (Type2 head, optical magnification 15x)

High reliability within the FOV.

Fast and high precision Auto-Focusing (2 Types)

Laser AF

Type 1, 2, and 3 zooming heads are equipped with TTL laser AF with a long working distance 50 mm. It can also be used for scanning the surface by detecting a maximum of 1000 points per second.



TTL Laser and AF schematic

Vision AF

Vision AF is suitable to measure the height of rough surfaces and depth of small/deep holes.

Versatile illumination designed for highlighting obscure edges

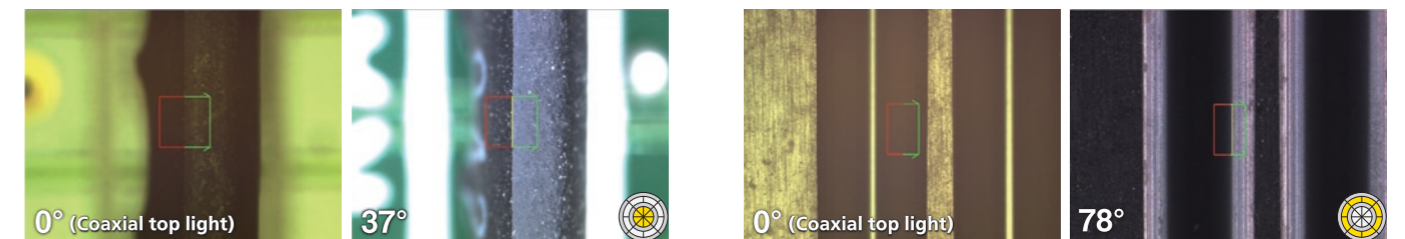
Standard NEXIV optical heads have episcopic, diascopic, and 8 segment LED ring illumination.



• LED inner ring light

• LED outer ring light at 55 degree position

• LED outer ring light at 78 degree position



• Coaxial top light / 37 degree oblique light (Connector at optical magnification 5x)

• Coaxial top light / 78 degree oblique light (Drill at optical magnification 5x)

Obscure edges under coaxial top light are visible with LED ring lights.

Improvement of the throughput < NEW

Throughput has improved by realizing faster short-distance stage movements. This contributes to the shortening of the measurement time.

Conventional NEXIV (VMZ-R3020)	182 sec.	34% less Measurement time
VMZ-S3020	120 sec.	

*Measurement of 625 (25x25) circle diameter. $\phi 50 \mu m$, Pitch: X,Y=0.2 mm, Stage speed: max, FOV: 0.58x0.44 mm. Same teaching file is used for measurement.

New design < NEW

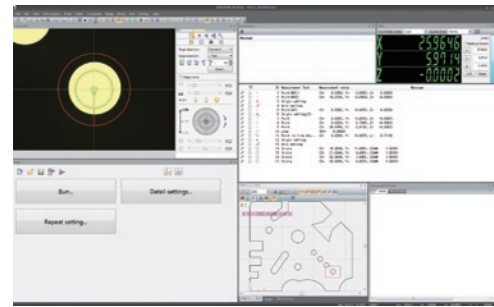
Along with the exterior design change, the joystick used for stage and optical head movements has been redesigned to make the operation easier and less tiring during long use.



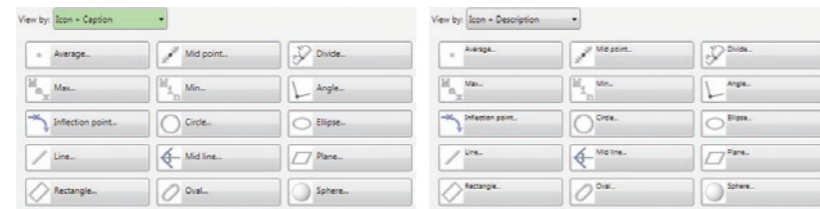
Software Easy to use, streamlined software suite

Dimension measurement software NEXIV AutoMeasure realizes high accuracy / high speed / easy measurement with valuable functions possible in a user-friendly GUI.

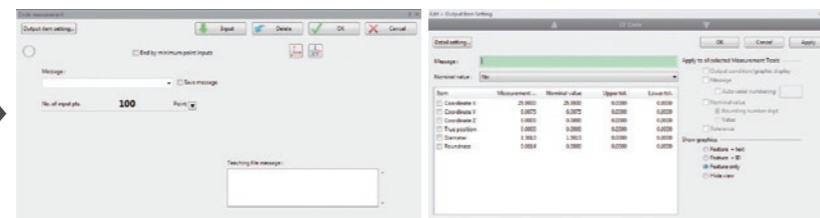
GUI for easier operations



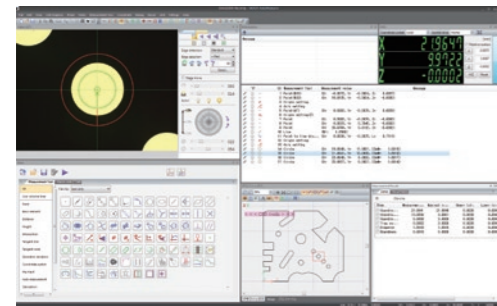
The graphical user interface (GUI) simplifies machine movement, creating and running teaching files, and clearly indicates status and progress of measurements.



Change of indication of measure tools



Main window changes its function according to situation.



Various wizards for guiding procedures of measurements are available, providing fast, easy writing of teaching files. GUI can be customized for different tasks. You can select and hide functions for achieving your tasks.

Measurement programming support* < NEW

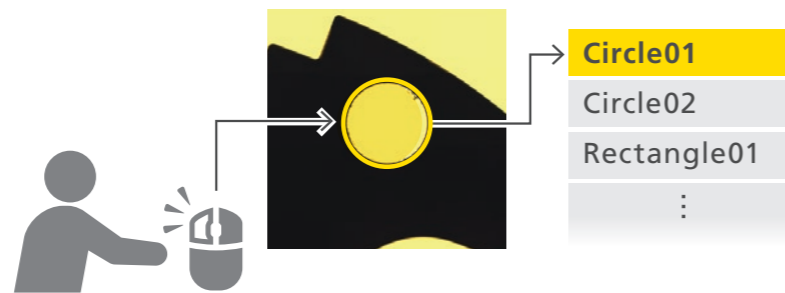
Supports part of the measurement program creating processes. By selecting the measurement point, several settings are handled by the system and measurement program code is created automatically.

Creating stitching image automatically

CAD data and image can be overlaid and compared automatically.

Creating measurement program code automatically

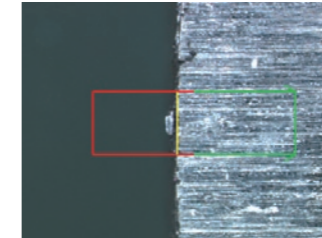
By selecting the shape you want to measure in the CAD/Image, the component shape is automatically recognized and a measurement program code is automatically created.



*This function is for workpieces with simple shape structure. Guide of conditions: With diascopic illumination. Components with perforations or voids which can clearly detect edge contours, without significant variations, or material contamination. (circle, rectangle, and circular arc)

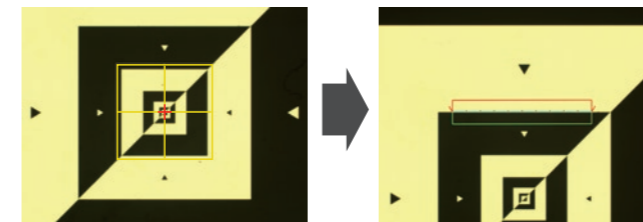
Edge and point selection

Preset rules for selecting the correct edge with multiple edge candidates and the filter to avoid abnormal points in order to minimize errors.

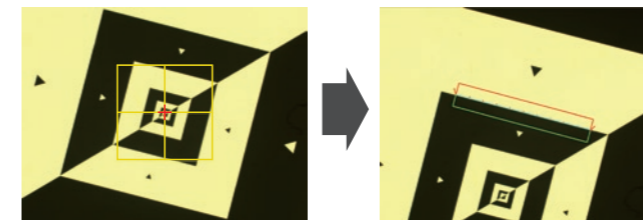


Intelligent search function

Measures by searching preset shapes/patterns. Misaligned samples can be found and measured without failure.



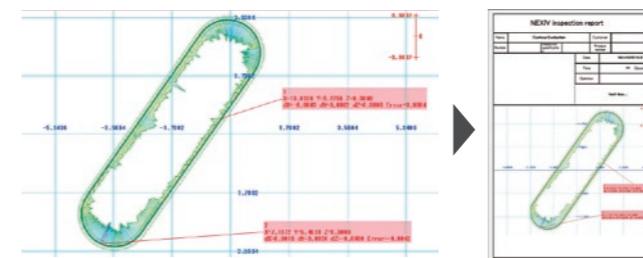
Automatically finds the shape that was set as a target



"Rotate search" detects the misaligned samples and automatically rotates the program to suit for measurement.

Evaluation of shapes

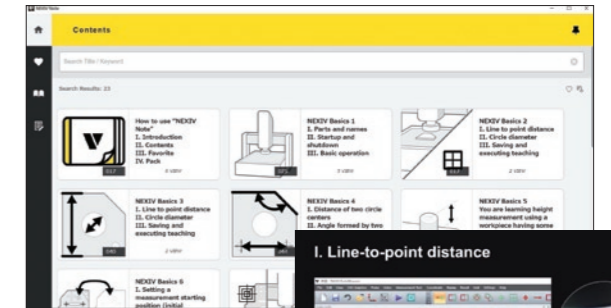
Errors can be visualized by overlaying nominal and measured shapes. Can be used for both geometrical shapes and free-form shapes.



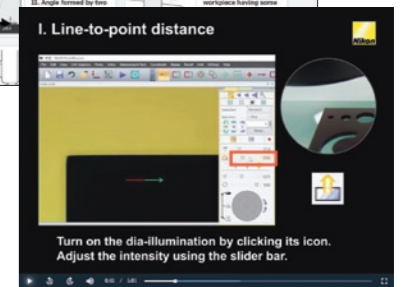
- Calculation of errors can be made in normal or axis direction
- Nominal shapes can be made from CAD data or XYZ coordinate values
- Measured shapes can be output as CSV or DXF files
- Evaluation reports can be made in PDF files

Digital operation guide NEXIV Note

The function offers slides and movie output together with NEXIV contents, such as basic operations and functions. Simple measurement programs can be created by referring to this application.

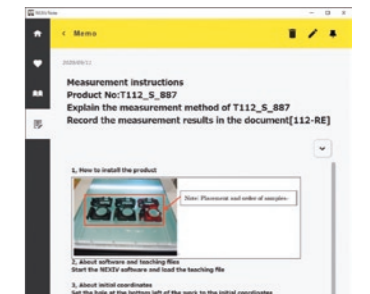


Content Example



Example of the function

- Memo: Share information by creating memos



Other functions

Import of CAD data

CAD data can be imported and shown in the graphic window.

Export of DXF data

Features measured can be exported as DXF data.

Off-line teaching

Teaching files can be made using CAD data.

Reporting measured data

Easily made by choosing the required graphics and layouts.

Calculations based on ISO and JIS standards

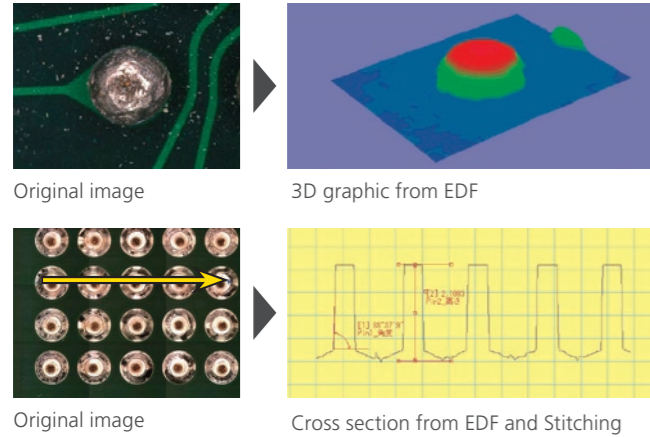
Circle (roundness), plane (flatness), line (straightness) are available.

Please contact your local Nikon partner.

Optional Software

EDF/Stitching Express

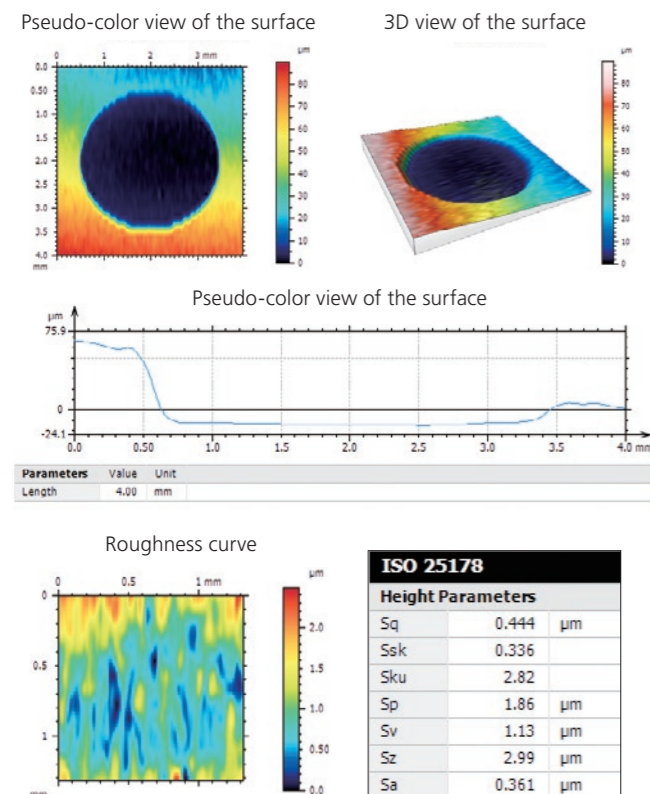
Images taken with the VMZ-S can be stitched to get a larger mosaic image, while images at different heights can result with an image with Extended Depth of Focus (EDF). Stitching and EDF can produce full 3D graphics.



MountainsMap X

Sample surfaces can be analyzed, based on ISO, with the data exported from VMZ-S.

Provided for Nikon by Digital Surf (France)



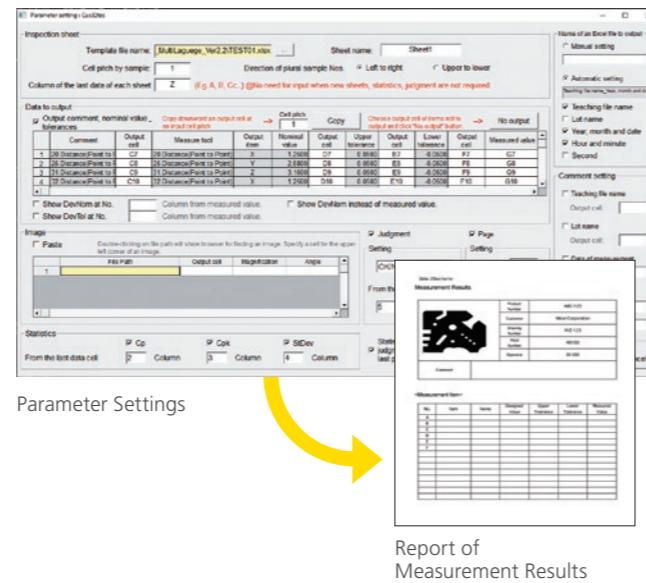
ImageFit QC

Creates inspection reports according to a designated format. Measurement results can be automatically be modified with a pass/fail result and statistical data.* Line graphs and histograms can also be created as needed.

*standard deviation, process capability index (Cp, Cpk)

*Excel is required

Codeveloped by Aria Co., Ltd. (Japan)

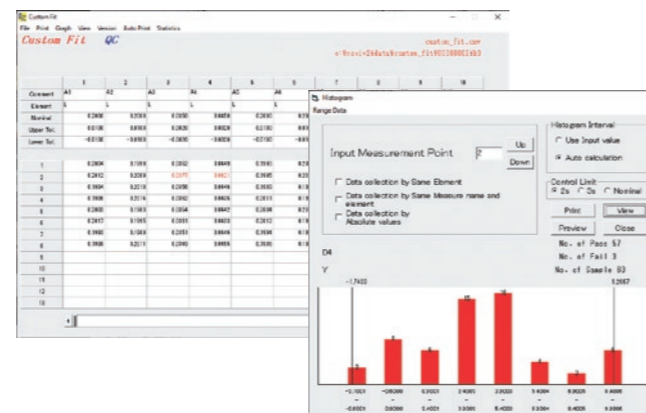


Custom Fit QC

Measurement results are read into 10 different templates and pass/fail results and calculation results*1 are automatically exported. Graphs*2, including X-R control charts and scatter diagrams, can be automatically generated to visualize measurement results.

*1: Average, maximum value, minimum value, range, standard deviation, and process capability index (Cp, Cpk)

*2: Line graphs, histograms, X-R control charts, scatter diagrams

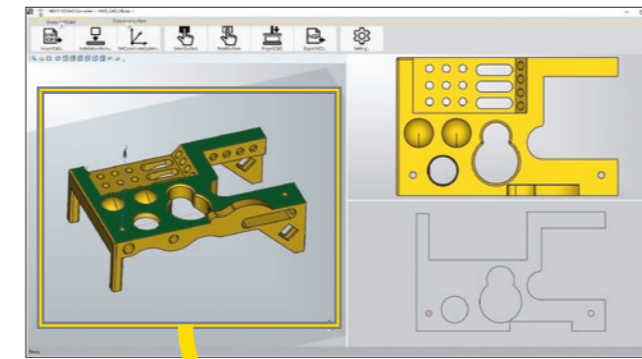


*Excel is required

Codeveloped by Aria Co., Ltd. (Japan)

3D CAD Converter

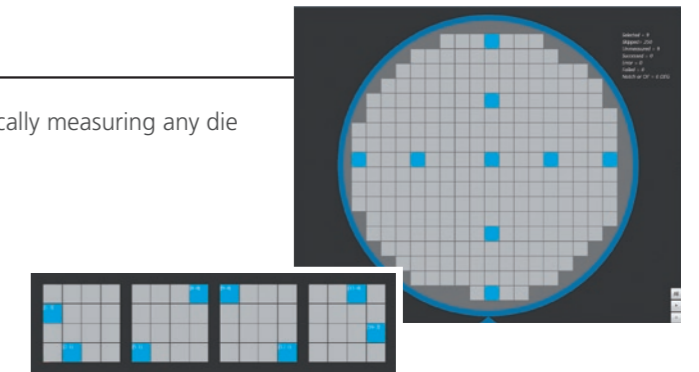
3DCAD model can be converted to 2DCAD(NCD) file, which can be used in NEXIV AutoMeasure. 2DCAD of the surface used for laser AF and scan laser can also be created. 3DCAD models are compatible with STEP and IGES files.



Convert to 2DCAD(NCD) file

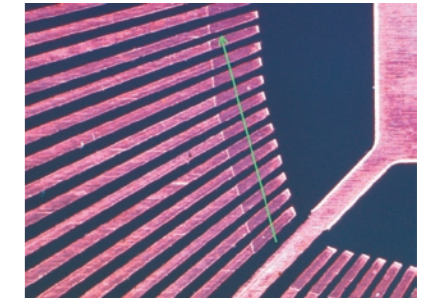
MapMeasure Pro

MapMeasure Pro creates wafer maps and is capable of automatically measuring any die on the wafer map. Tray maps can also be created.



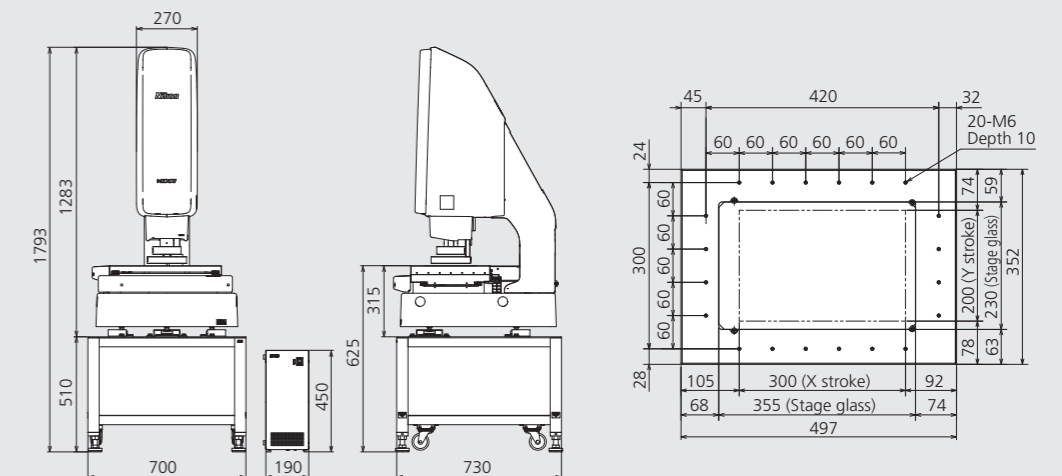
Application for lead frame measurement

Suitable for the measurement of lead frames like widths and intervals that are necessary for quality control. By utilizing auto-scan function, teaching file can be created easily.



Auto-scan and measuring the lengths between the leads

Dimension VMZ-S3020



Specifications

Model	VMZ-S3020			
XYZ strokes	300×200×200 mm *Type TZ with low magnification lens: 250×200×200 mm			
Minimum readout	0.01 μm			
Maximum sample weight	20 kg (Accuracy guaranteed: 5 kg)			
Maximum permissible error (L: Length in mm)	EUX, MPE 1.2 + 4L / 1000 μm	EUY, MPE	EUXY, MPE 2.0 + 4L / 1000 μm	EUZ, MPE 1.2 + 5L / 1000 μm
	Probing error ^{1),2)} : MPE P _{F2D} 0.8 μm Probing error of the imaging probe ^{1),2)} : MPE P _{FV2D} 0.3 μm			
Camera	Black and White / Color 1/3 CMOS Camera			
Working distance	Type 1, 2 and 3	Type 4	Type TZ	Type A
	50 mm	30 mm	(High-mag.) 11 mm / (Low-mag.) 32 mm	73.5 mm (63 mm with Laser AF)
Autofocus	Laser AF (Option for Type A) / Image AF			
Laser AF repeatability range ^{1),3)}	2σ ≤ 0.5 μm			
Illumination	Type 1, 2, 3, and 4 : Episcopic, diascopic, and 8-segment ring with 3 angles *All white LED/Type 4 has only 1 angle			
	Type TZ: Left objective lens: Episcopic, darkfield ; Right objective lens: Episcopic, diascopic, darkfield Type A: Episcopic, diascopic, and 8-segment ring with 1 angle *All white LED			
Power source, Power consumption	AC100 V-240 V, 50/60 Hz / 4 A – 2 A			
Dimensions & weight	Main body with table (W×D×H): 700×730×1793 mm / approx. 265 kg Controller: 190×450×450 mm / approx. 12 kg			
Footprint (W×D)	2700×2400 mm			

1) Determined by Nikon in-house measurement method. 2) With Type 2 head, 15×. 3) Workpiece: Chrome on calibration plate, without Type A head.

VMZ-S series
scheduled to be released in 2021

VMZ-S4540 Stroke (X,Y,Z) 450×400×200 mm

VMZ-S6555 Stroke (X,Y,Z) 650×550×200 mm



Please contact Nikon for details.

Nikon Corporation Industrial Metrology Business Unit is certified as an ISO/IEC 17025 accredited calibration laboratory for CNC video measuring systems by the IAJapan (International Accreditation Japan) as Accreditation No. JCSS0241.

ISO/IEC 17025: International standard, which specifies the general requirements to ensure that a laboratory is competent to carry out specific tests and/or calibrations

Date of initial accreditation:	November 22, 2010
Scope of accreditation:	Coordinate measuring instruments
Accredited section:	Industrial Metrology Business Unit
Calibration site:	Customer's laboratory (field service)
Calibration and Measurement Capability (CMC), (K=2, Level of Confidence Approximately 95%) [L=measurement length (mm)]	L ≤ 420 mm: 0.32 μm
	420 ≤ L ≤ 1000 mm : (0.29 + 0.64 × L/1000) μm

Specifications and equipment are subject to change without any notice or obligation on the part of the manufacturer. November 2020 ©2020 NIKON CORPORATION
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WARNING TO ENSURE CORRECT USAGE, READ THE CORRESPONDING MANUALS CAREFULLY BEFORE USING THE EQUIPMENT.

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